



STIC Search Report

EIC 2800

HEATER TUBES

STIC Database Tracking Number: 106874

TO: David Rogers
Location: CP4 8D05
Art Unit : 2856
Tuesday, October 28, 2003

Case Serial Number: 09943189

From: Bode Fagbohunka
Location: EIC 2800
CP4-9C18
Phone: 703-605-1726

bode.fagbohunka@uspto.gov

Search Notes

Examiner Rogers,

Please find attached the results of your search for 09943189. The search was conducted using the standard collection of databases on dialog for EIC 2800. The tagged references appear to be the closest references located during our search.

If you would like a re-focus please let me know or if you have any questions regarding the search results please do not hesitate to contact me.

Bode Fagbohunka

Set	Items	Description
S1	45462	ROLL?()BURN? OR COLD()WORK? OR COLDWORKING? OR BURNISH?
S2	70508	(SURFAC??? OR POLISH?) (2N) FINISH?
S3	1225817	NM OR NANO()METER? OR NANOMETER?
S4	240	S2(6N)S3
S5	5	S4 AND S1
S6	2	RD (unique items)
S7	134	S2(3N)S3
S8	25	S7 AND PD<=20000831
S9	20	RD (unique items)
S10	20	S9 NOT S6
S11	746	S1 AND S2
S12	199	S1(6N)S2
S13	4	S12 AND S3
S14	1	RD (unique items)

? show files

File 2:INSPEC 1969-2003/Oct W3
(c) 2003 Institution of Electrical Engineers

File 6:NTIS 1964-2003/Oct W4
(c) 2003 NTIS, Intl Cpyrght All Rights Res

File 8:Ei Compendex(R) 1970-2003/Oct W3
(c) 2003 Elsevier Eng. Info. Inc.

File 31:World Surface Coatings Abs 1976-2003/Sep
(c) 2003 Paint Research Assn.

File 34:SciSearch(R) Cited Ref Sci 1990-2003/Oct W3
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File 434:SciSearch(R) Cited Ref Sci 1974-1989/Dec
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File 40:Enviroline(R) 1975-2003/Sep

File 65:Inside Conferences 1993-2003/Oct W4
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File 35:Dissertation Abs Online 1861-2003/Sep
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File 317:Chemical Safety NewsBase 1981-2003/Oct
(c) 2003 Royal Soc Chemistry

File 144:Pascal 1973-2003/Oct W3
(c) 2003 INIST/CNRS

File 114:Encyclopedia of Associations 2003/Sep
(c) 2003 Gale Research Inc.

File 103:Energy SciTec 1974-2003/Oct B1
(c) 2003 Contains copyrighted material

File 99:Wilson Appl. Sci & Tech Abs 1983-2003/Sep
(c) 2003 The HW Wilson Co.

File 94:JICST-EPlus 1985-2003/Oct W4
(c)2003 Japan Science and Tech Corp(JST)

File 161:Occ.Saf.& Hth. 1973-1998/Q3
(c) Format only 1998 The Dialog Corp.

File 440:Current Contents Search(R) 1990-2003/Oct 28
(c) 2003 Inst for Sci Info

File 439:Arts&Humanities Search(R) 1980-2003/Oct W3
(c) 2003 Inst for Sci Info

File 437:Education Abstracts 1983-2003/Sep
(c) 2003 The HW Wilson Co

File 420:UnCover 1988-2001/May 31
(c) 2001 The UnCover Company

File 347:JAPIO Oct 1976-2003/Jun(Updated 031006)
(c) 2003 JPO & JAPIO

File 350:Derwent WPIX 1963-2003/UD,UM &UP=200369

(c) 2003 Thomson Derwent

6/9/1 (Item 1 from file: 8)
DIALOG(R) File 8: Ei Compendex(R)
(c) 2003 Elsevier Eng. Info. Inc. All rts. reserv.

05918350 E.I. No: EIP01436699985

Title: Ultra-precision grinding of hard steels

Author: Stephenson, D.J.; Veselovac, D.; Manley, S.; Corbett, J.

Corporate Source: Sch. of Indust. and Mfg. Science Cranfield University, Cranfield, Beds., MK43 0AL, United Kingdom

Source: Precision Engineering v 25 n 4 October 2001. p 336-345

Publication Year: 2001

CODEN: PREGDL **ISSN:** 0141-6359

Language: English

Document Type: JA; (Journal Article) **Treatment:** T; (Theoretical); X; (Experimental)

Journal Announcement: 0110W4

Abstract: Hardened bearing steel, M50, has been ultra-precision ground to produce an optical quality surface (less than 10 nm R//a) using a novel ultra-stiff machine tool, Tetraform 'C'. It has been shown that a repeatable surface finish of less than 10 nm R//a can be produced using a 76 µm CBN grit and 500 µm wheel depth of cut. This represents a significant improvement over previous published work using conventional precision machine tools where nanometre surface finish can only be obtained at the expense of process efficiency. The development of optical quality surfaces is considered in terms of the processes occurring in the primary and secondary finishing zones of the cup-wheel, with the final surface finish enhanced by the burnishing action of worn CBN grits. It is shown that surface finish is limited by the pull-out of carbides in the secondary finishing zone. However, this can be overcome by using electrolytic in-process dressing (ELID), which maintains CBN grit protrusion and sharpness. This promotes cutting of the carbides at the ground surface and ensures a high level of surface integrity although the burnishing action of grits is reduced resulting in a slightly higher roughness for the steel matrix. copy 2001 Elsevier Science Inc. All rights reserved. 13 Refs.

Descriptors: Steel; Grinding (machining); Surface testing; Metal finishing; Carbides; Burnishing; Electrolytic analysis; Machine tools; Precision engineering

Identifiers: Optical quality surfaces; Ultra-precision grinding; Electrolytic in-process dressing (ELID)

Classification Codes:

801.4.1 (Electrochemistry)

545.3 (Steel); 604.2 (Machining Operations); 423.2 (Test Methods); 804.2 (Inorganic Compounds); 812.1 (Ceramics); 801.4 (Physical Chemistry); 603.1 (Machine Tools, General)

545 (Iron & Steel); 604 (Metal Cutting & Machining); 423 (Non Mechanical Properties & Tests of Building Materials); 804 (Chemical Products Generally); 812 (Ceramics, Refractories & Glass); 539 (Metals Corrosion & Protection; Metal Plating); 801 (Chemistry); 603 (Machine Tools)

54 (METALLURGICAL ENGINEERING, METAL GROUPS); 60 (MECHANICAL ENGINEERING, GENERAL); 42 (BUILDING MATERIALS PROPERTIES & TESTING); 80 (CHEMICAL ENGINEERING, GENERAL); 81 (CHEMICAL ENGINEERING, PROCESS INDUSTRIES); 53 (METALLURGICAL ENGINEERING, GENERAL)

6/9/2 (Item 1 from file: 94)
DIALOG(R) File 94: JICST-EPlus
(c) 2003 Japan Science and Tech Corp (JST). All rts. reserv.

05247017 JICST ACCESSION NUMBER: 02A0726781 FILE SEGMENT: JICST-E
Mechanism of the Surface Finish Generation in Ultraprecision Cutting of
Al-Mg Alloy.

NAKAJIMA TOSHIKATSU (1); OHASHI KAZUHITO (1); YOSHIKAWA MITSUO (2);
HIGASHIMOTO OSAMU (3); KINME SHIGETAKA (3)

(1) Okayama Univ., Faculty of Engineering, JPN; (2) Okayama Prefecture Ind.
Technol. Center, JPN; (3) Okayama Univ., Graduate School, JPN

Seimitsu Kogakkaishi (Journal of the Japan Society for Precision Engineering
) , 2002, VOL.68, NO.9, PAGE.1221-1225, FIG.13, REF.10

JOURNAL NUMBER: F0268ABQ ISSN NO: 0912-0289

UNIVERSAL DECIMAL CLASSIFICATION: 621.91

LANGUAGE: Japanese COUNTRY OF PUBLICATION: Japan

DOCUMENT TYPE: Journal

ARTICLE TYPE: Original paper

MEDIA TYPE: Printed Publication

ABSTRACT: In ultraprecision cutting by which **surface finish** is **nano - meter** order, the problems which are not necessary to consider in ordinary cutting occur. One of these is the step at grain boundary on machined surface which is generated by the difference of elastic recovery of crystal grains after cutting edge passing because of mechanical characteristics of crystal grain affected by crystal direction. In this study, in order to make clear the mechanism of the surface finish generation in ultraprecision cutting of Al-Mg alloy, the relationship between clearance angle of tool and surface finish is analyzed quantitatively taking notice of step at grain boundary. As a result, it is confirmed that **burnishing** effect with clearance of cutting tool, which strengthen with a decrease of clearance angle, improves surface finish in ultraprecision cutting of Al-Mg alloy.
(author abst.)

DESCRIPTORS: ultraprecision machining; cutting(machining); lathe; mirror finishing; aluminum base alloy; magnesium containing alloy; surface roughness; diamond tool; cutting edge; tool angle; machined surface; grain boundary; orientation(direction); residual stress

BROADER DESCRIPTORS: precision machining; working and processing; machining; machine tool; machinery; polishing(machining); light alloy; nonferrous alloy; alloy; metallic material; containing alloy; surface quality; flatness(property); property; carbide tool; tool; cutting part; angle; geometric quantity; face; boundary; stress(mechanics)

CLASSIFICATION CODE(S): QC02010V

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10/9/1 (Item 1 from file: 34)
DIALOG(R) File 34:SciSearch(R) Cited Ref Sci
(c) 2003 Inst for Sci Info. All rts. reserv.

08033245 Genuine Article#: 239FQ Number of References: 34
Title: Precision grinding and facing of copper-beryllium alloys
Author(s): Hung NP (REPRINT) ; Zhong ZW; Lee KK; Chai CF
Corporate Source: NANYANG TECHNOL UNIV, SCH MECH & PROD ENGN, NANYANG
AVE/SINGAPORE 639798//SINGAPORE/ (REPRINT)
Journal: PRECISION ENGINEERING-JOURNAL OF THE AMERICAN SOCIETY FOR
PRECISION ENGINEERING, 1999, V23, N4 (OCT), P293-304
ISSN: 0141-6359 Publication date: 19991000
Publisher: ELSEVIER SCIENCE INC, 655 AVENUE OF THE AMERICAS, NEW YORK, NY
10010

Language: English Document Type: ARTICLE

Geographic Location: SINGAPORE

Subfile: CC ENGI--Current Contents, Engineering, Computing & Technology

Journal Subject Category: INSTRUMENTS & INSTRUMENTATION; ENGINEERING,
MANUFACTURING; ENGINEERING

Abstract: This paper investigates the machinability of Cu-Be alloys by ultraprecision grinding and facing. The material temper, tool geometry, and machining parameters are varied to assess their effects on surface finish. The study shows that microgrinding of Cu-Be with a diamond wheel generates a rougher surface finish as compared to that produced by microfacing with a single-point diamond tool. Similar chip formation mechanisms are observed when the depths of cut vary from few millimeters to submicron levels. A mathematical model is derived to compare the theoretical and experimental surface finish. Good agreement between predicted and measured data is obtained, providing grain boundaries are visible on a machined surface when being observed under a microscope. Feedrate and tool radius are the most influential parameters on **surface finish**. Flatness of 20 nm on the 9.5 mm diameter rod and roughness of 2 nm R-a and 8 nm R-t are achieved. Although the material's micromachinability is the same for both the aged and unaged alloys, size and distribution of beryllides must be controlled for better tool life and surface finish. (C) 1999 Elsevier Science Inc. All rights reserved.

Descriptors--Author Keywords: ultraprecision machining ; copper beryllium ; chip formation ; diamond turning ; surface finish ; microgrinding

Identifiers--KeyWord Plus(R): METAL-MATRIX COMPOSITES; CUMULATIVE TOOL WEAR; MICROCUTTING PROCESSES; DIAMOND

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10/9/2 (Item 2 from file: 34)

DIALOG(R) File 34:SciSearch(R) Cited Ref Sci
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06589208 Genuine Article#: ZD144 Number of References: 19
Title: On the finishing of Si₃N₄ balls for bearing applications
 Author(s): Jiang M; Komanduri R (REPRINT)
 Corporate Source: OKLAHOMA STATE UNIV, 218 ENGN N/STILLWATER//OK/74078
 (REPRINT); OKLAHOMA STATE UNIV, /STILLWATER//OK/74078
 Journal: WEAR, 1998, V215, N1-2 (MAR), P267-278
 ISSN: 0043-1648 Publication date: 19980300
 Publisher: ELSEVIER SCIENCE SA, PO BOX 564, 1001 LAUSANNE, SWITZERLAND
 Language: English Document Type: ARTICLE
 Geographic Location: USA
 Subfile: CC ENGI--Current Contents, Engineering, Computing & Technology
 Journal Subject Category: MATERIALS SCIENCE; ENGINEERING, MECHANICAL
 Abstract: The conventional method of producing of Si₃N₄ balls for bearing applications by grinding and lapping using diamond abrasive at low speeds (<a few hundred rpm) and higher loads (several tens of N/ball) is generally an expensive and time-consuming operation (several weeks). It also leads to the formation of scratches, microcracks, and pits on the finished balls resulting from large radial and circumferential cracks and dislodgement of grains. Since failure of ceramics initiates from such defects, the reliability of Si₃N₄ balls in service is of prime concern. This paper deals with an alternate technology for finishing Si₃N₄ balls for hybrid bearing applications using magnetic float polishing (MFP) process that overcomes some of these limitations. A methodology for finishing of HIP'ed Si₃N₄ balls from the as-received condition by MFP is presented. It involves the mechanical removal of material initially using harder abrasives with respect to the workmaterial (of different materials of progressively lower hardnesses and finer grain sizes) followed by final chemo-mechanical polishing (CMP) using preferably a softer abrasive for obtaining superior finish with minimal surface or subsurface defects, such as scratches, microcracks, or pits on the Si₃N₄ balls. High material removal rates (1 μ m/min) with minimal subsurface damage is obtained with harder abrasives, such as B₄C or SiC (relative to Si₃N₄) due to the use of a flexible support system, small polishing loads (approximate to 1 N/ball), and fine abrasives but high polishing speeds (compared to conventional polishing) by rapid accumulation of minute amounts of material removed by microfracture. Final polishing of the Si₃N₄ balls using a softer abrasive, such as CeO₂ (that chemo-mechanically react with the Si₃N₄ workmaterial) results in high quality Si₃N₄ balls of bearing quality with superior surface finish (R-a < 4 nm, R-t <

0.04 μ m) and damage-free surface. It is found that CMP is very effective for obtaining excellent surface finish (R-a approximate to 4 nm and R-t approximate to 40 nm) on Si₃N₄ ceramic material and CeO₂ in particular is one of most suitable material for this application. (C) 1998 Elsevier Science S.A.

Descriptors--Author Keywords: magnetic float polishing ; finishing of ceramic balls ; silicon nitride ; chemo-mechanical polishing (CMP) ; cerium oxide

Cited References:

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10/9/9 (Item 3 from file: 103)

DIALOG(R)File 103:Energy SciTec

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04155734 LLNL-97-M97051636; EDB-97-064438

Title: Simulations of laser imprint for Nova experiments and for ignition capsules. Revision 1

Author(s)/Editor(s): Weber, S.V.; Glendinning, S.G.; Kalantar, D.H.; Key, M.H.; Remington, B.A.; Rothenberg, J.L. (Lawrence Livermore National Lab., CA (United States)); Wolfrum, E. (Rutherford Appleton Lab., Chilton (United Kingdom)); Verdon, C.P.; Knauer, J.P. (Rochester Univ., NY (United States). Lab. for Laser Energetics)

Corporate Source: Lawrence Livermore National Lab., CA (United States)
(Code: 9513035)

Sponsoring Organization: DOE/DP; USDOE Assistant Secretary for Defense Programs, Washington, DC (United States)

Conference Title: Meeting of the Division of Plasma Physics of the American Physical Society

Conference Location: Denver, CO (United States) Conference Date: 11-15 Nov 1996

Publication Date: Dec 1996

(33 p)

Report Number(s): UCRL-JC-124547-Rev.1 CONF-961102--8

Order Number: DE97051636

Contract Number (DOE): W-7405-ENG-48

Document Type: Report; Conference Literature

Language: English

Journal Announcement: EDB9710

Availability: OSTI; NTIS; INIS; GPO Dep.

Distribution: (Report):H (MF):4 MN-712

Subfile: ETD (Energy Technology Data Exchange); INS (US Atomindex input);

NTS (NTIS).

US DOE Project/NonDOE Project: P

Country of Origin: United States

Country of Publication: United States

Abstract: In direct drive ICF, nonuniformities in laser illumination seed ripples at the ablation front in a process called 'imprint'. These nonuniformities grow during the capsule implosion and, if initially large enough, can penetrate the capsule shell, impede ignition, or degrade burn. Imprint has been simulated for recent experiments performed on the Nova laser at LLNL examining a variety of beam smoothing conditions. Most used laser intensities similar to the early part of an ignition capsule pulse shape, $1 \approx 10^{13}$ W/cm². The simulations matched most of the measurements of imprint modulation. The effect of imprint upon National Ignition Facility (NIF) direct drive ignition capsules has also been simulated. Imprint is predicted to give modulation comparable to an intrinsic surface finish of approximately 10 nm RMS. Modulation growth was examined using the Haan [Phys. Rev. A **39**, 5812 (1989)] model, with linear growth factors as a function of spherical harmonic mode number obtained from an analytic dispersion relation. Ablation front amplitudes are predicted to become substantially nonlinear, so that saturation corrections are large. Direct numerical simulations of two-dimensional multimode growth were also performed. The capsule shell is predicted to remain intact, which gives a basis for believing that ignition can be achieved. 27 refs., 10 figs.

Major Descriptors: *ABLATION -- COMPUTERIZED SIMULATION; *ABLATION -- VARIATIONS; *CAPSULES -- ABLATION; *CAPSULES -- NONUNIFORM IRRADIATION; *DIRECT DRIVE LASER IMPLOSION -- COMPUTERIZED SIMULATION; *ICF DEVICES -- PERFORMANCE; *NOVA FACILITY -- PERFORMANCE; *VARIATIONS -- COMPUTERIZED SIMULATION

Broader Terms: CONTAINERS; IMPLOSIONS; IRRADIATION; LASER IMPLOSIONS; SIMULATION; THERMONUCLEAR DEVICES

Subject Categories: 700411* -- Inertial Confinement Devices -- (1992-)

INIS Subject Categories: G5211* -- Inertial confinement devices -- (1992-)

10/9/11 (Item 5 from file: 103)

DIALOG(R) File 103:Energy SciTec

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03944448 EDB-96-028208

Title: Fabrication of polymer shells using a depolymerizable mandrel

Author(s): Letts, S.A.; Fearson, E.M.; Buckley, S.R.; Saculla, M.D.; Allison, L.M.; Cook, R. (Lawrence Livermore National Lab., CA (United States))

Source: Fusion Technology v 28:5. Coden: FUSTE8 ISSN: 0748-1896

Publication Date: Dec 1995

p 1797-1802

Contract Number (DOE): W-7405-ENG-48

Document Type: Journal Article

Language: English

Journal Announcement: EDB9604

Subfile: ETD (Energy Technology Data Exchange); INS (US Atomindex input).
IIA (DOE contractor)

US DOE Project/NonDOE Project: P

Country of Origin: United States

Country of Publication: United States

Abstract: A new technique for producing hollow shell laser fusion fuel capsules has been developed that starts with a depolymerizable mandrel. In this technique we use poly([alpha]-methylstyrene) (PAMS) beads or shells as mandrels which are overcoated with plasma polymer. The PAMS

mandrel is thermally depolymerized to gas phase monomer. which diffuses through the permeable and thermally more stable plasma polymer coating, leaving a hollow shell. Using this technique we made shells from 200 [mu]m to 4 mm diameter with 15 to 100 [mu]m wall thickness having sphericity better than 0.5 [mu]m and surface finish better than 10 nm RMS. 13 refs., 5 figs., 1 tab.

Major Descriptors: *FUEL PELLETS -- FABRICATION; *POLYSTYRENE -- USES;
*SHELLS -- FABRICATION

Descriptors: DEPOLYMERIZATION; IMPACT FUSION; INERTIAL CONFINEMENT; PLASMA; POLYMERS; TARGETS

Broader Terms: CHEMICAL REACTIONS; CONFINEMENT; DECOMPOSITION; MATERIALS; NUCLEAR REACTIONS; NUCLEOSYNTHESIS; ORGANIC COMPOUNDS; ORGANIC POLYMERS; PELLETS; PETROCHEMICALS; PETROLEUM PRODUCTS; PLASMA CONFINEMENT; PLASTICS; POLYMERS; POLYOLEFINS; POLYVINYL; SYNTHESIS; SYNTHETIC MATERIALS; THERMONUCLEAR REACTIONS

Subject Categories: 360600* -- Other Materials

360601 -- Other Materials -- Preparation & Manufacture

700411 -- Inertial Confinement Devices -- (1992-)

700460 -- Fusion Technology -- Heating & Fueling Systems; Fuels -- (1992)

700480 -- Fusion Technology -- Component Development; Materials Studies -- (1992-)

INIS Subject Categories: B2400* -- Other Materials

B2410 -- Other Materials -- Preparation & manufacture

G5211 -- Inertial confinement devices -- (1992-)

G5260 -- Fusion Technology -- Heating & fueling systems; fuels -- (1992-)

G5280 -- Fusion Technology -- Component development; materials studies -- (1992-)

10/9/12 (Item 6 from file: 103)

DIALOG(R) File 103:Energy SciTec

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03928105 EDB-96-011865

Title: Preparation of hollow shell ICF targets using a depolymerizing model

Author(s)/Editor(s): Letts, S.A.; Fearon, E.M.; Buckley, S.R. (and others)

Corporate Source: Lawrence Livermore National Lab., CA (United States)

(Code: 9513035)

Sponsoring Organization: DOE; USDOE, Washington, DC (United States)

Conference Title: Fall meeting of the Materials Research Society

Conference Location: Boston, MA (United States) **Conference Date:** 28 Nov - 2 Dec 1994

Publication Date: Nov 1994

(8 p)

Report Number(s): UCRL-JC-119346 CONF-941144--175

Order Number: DE96002564

Contract Number (DOE): W-7405-ENG-48

Document Type: Report; Conference Literature

Language: English

Journal Announcement: EDB9602

Availability: OSTI; NTIS; INIS; GPO Dep.

Distribution: (Report):0 (MF):4 MN-712

Subfile: ERA (Energy Research Abstracts); ETD (Energy Technology Data Exchange); INS (US Atomindex input); NTS (NTIS). IIA (DOE contractor)

US DOE Project/NonDOE Project: P

Country of Origin: United States

Country of Publication: United States

Abstract: A new technique for producing hollow shell laser fusion capsules was developed that starts with a depolymerizable mandrel. In this

technique we use poly(alpha-methylstyrene) (PAMS) beads or shells as mandrels which are overcoated with plasma polymer. The PAMS mandrel is thermally depolymerized to gas phase monomer, which diffuses through the permeable and thermally more stable plasma polymer coating, leaving a hollow shell. We have developed methods for controlling the size of the PAMS mandrel by either grinding to make smaller sizes or melt sintering to form larger mandrels. Sphericity and surface finish are improved by heating the PAMS mandrels in hot water using a surfactant to prevent aggregation. Using this technique we have made shells from 200 [mu]m to 5 mm diameter with 15 to 100 [mu]m wall thickness having sphericity better than 2 [mu]m and surface finish better than 10 nm RMS.

Major Descriptors: *LASER TARGETS -- DESIGN; *LASER TARGETS -- PRODUCTION
Descriptors: DEPOLYMERIZATION; ICF DEVICES; SHELLS; TEMPERATURE DEPENDENCE;
THERMAL ANALYSIS

Broader Terms: CHEMICAL REACTIONS; DECOMPOSITION; TARGETS; THERMONUCLEAR
DEVICES

Subject Categories: 700411* -- Inertial Confinement Devices -- (1992-)

INIS Subject Categories: G5211* -- Inertial confinement devices -- (1992-)

10/9/13 (Item 7 from file: 103)

DIALOG(R) File 103:Energy SciTec

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03925354 EDB-96-009114

Title: Friction and wear properties of smooth diamond films grown in
fullerene-argon plasmas

Author(s)/Editor(s): Erdemir, A.; Fenske, G.R.; Bindal, C.; Zuiker, C.;
Krauss, A.R.; Gruen, D.M.

Corporate Source: Argonne National Lab., IL (United States) (Code:
0448000)

Sponsoring Organization: DOE; USDOE, Washington, DC (United States)

Conference Title: 6. European conference on diamond, diamond-like and
related materials

Conference Location: Barcelona (Spain) Conference Date: 10-15 Sep 1995

Publication Date: Aug 1995

(30 p)

Report Number(s): ANL/ET/CP-87528 CONF-9509137--1

Order Number: DE96002774

Contract Number (DOE): W-31109-ENG-38

Document Type: Report; Conference Literature

Language: English

Journal Announcement: EDB9602

Availability: OSTI; NTIS; GPO Dep.

Distribution: (Report):A (MF):4 MN-404

Subfile: ERA (Energy Research Abstracts); ETD (Energy Technology Data
Exchange); NTS (NTIS). TIC (Technical Information Center)

US DOE Project/NonDOE Project: P

Country of Origin: United States

Country of Publication: United States

Abstract: In this study, we describe the growth mechanism and the ultralow friction and wear properties of smooth (20-50 nm rms) diamond films grown in a microwave plasma consisting of Ar and fullerene (the carbon source). The sliding friction coefficients of these films against Si₃N₄ balls are 0.04 and 0.1 in dry N₂ and air, which are comparable to that of natural diamond sliding against the same pin material, but is lower by factors of 5 to 10 than that afforded by rough diamond films grown in conventional H₂-CH₄ plasmas. Furthermore, the smooth diamond films produced in this work afforded wear rates to Si₃N₄ balls that were two to three orders of

magnitude lower than those of H₂-CH₄ grown films. Mechanistically, the ultralow friction and wear properties of the fullerene-derived diamond films correlate well with their initially smooth surface finish and their ability to polish even further during sliding. The wear tracks reach an ultrasMOOTH (3-6 nm rms) **surface finish** that results in very little abrasion and ploughing. The nanocrystalline microstructure and exceptionally pure sp³ bonding in these smooth diamond films were verified by numerous surface and structure analytical methods, including x-ray diffraction, high-resolution AF-S, EELS, NEXAFS, SEM, and TEM. An AFM instrument was used to characterize the topography of the films and rubbing surfaces.

Major Descriptors: *DIAMONDS -- SLIDING FRICTION; *DIAMONDS -- WEAR RESISTANCE

Descriptors: FILMS; SILICON NITRIDES

Broader Terms: CARBON; ELEMENTAL MINERALS; ELEMENTS; FRICTION; MECHANICAL PROPERTIES; MINERALS; NITRIDES; NITROGEN COMPOUNDS; NONMETALS; Pnictides; SILICON COMPOUNDS

Subject Categories: 360603* -- Materials -- Properties

10/9/14 (Item 8 from file: 103)
DIALOG(R) File 103:Energy SciTec
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03637759 EDB-94-053725

Title: The effects of process parameters on the surface finish of plasma polymers

Author(s): Letts, S.A.; Cook, R.C.; Welch, P.; McEachern, R.; Fearon, E. (Lawrence Livermore National Laboratory, CA (United States))

Title: 205th ACS national meeting

Conference Title: 205. American Chemical Society national meeting

Conference Location: Denver, CO (United States) Conference Date: 28 Mar - 2 Apr 1993

Publisher: Washington, DC (United States) American Chemical Society

Publication Date: 1993

p 323, Paper POLY 193 (1951 p)

Report Number(s): CONF-930304--

Document Type: Analytic of a Book; Conference Literature

Language: English

Journal Announcement: EDB9408

Availability: American Chemical Society, Room 420, 1155 16th St., N.W., Washington, DC 20036-4899 (United States)

Subfile: ETD (Energy Technology Data Exchange). IIA (DOE contractor)

US DOE Project/NonDOE Project: P

Country of Origin: United States

Country of Publication: United States

Abstract: The surface finish of plasma polymers deposited in an inductively coupled discharge were measured as a function of gas flow rates. Surface finish was measured both optically and by AFM. The process parameters of the plasma polymerization were found to affect the surface finish. The gases used were trans-2-butene and hydrogen for hydrocarbon polymers. For bromocarbon polymers the authors added ethylbromide. The smoothest hydrocarbon polymer coatings has an RMS **surface finish** better than 1 nm. Bumps 200 nm high spaced approximately 1 [mu] apart grew on the surface of bromocarbon coatings when they were exposed to air. The composition of the bumps was found to be NH₄Br by XRD and XPS analysis. The authors believe that nitrogen (from a small leak or desorption) dissociates in the discharge and reacts with hydrogen to form ammonia. The ammonia then reacts with HBr, a dissociation product of ethylbromide, to form NH₄Br which is dispersed throughout the deposited layer. Humidity facilitates the

transport of the NH₄Br to the surface where it crystallizes. Bump growth was prevented by either dry storage or overcoating with 3 μ m of hydrocarbon plasma polymer. Alternatively, the bumps could be washed from the surface with water.

Major Descriptors: *HYDROCARBONS -- BROMINATION; *HYDROCARBONS -- POLYMERIZATION; *ORGANIC POLYMERS -- SURFACE FINISHING; *ORGANIC POLYMERS -- SURFACE PROPERTIES; *SURFACE FINISHING -- PROCESS CONTROL
Descriptors: PARAMETRIC ANALYSIS
Broader Terms: CHEMICAL REACTIONS; CONTROL; HALOGENATION; ORGANIC COMPOUNDS; POLYMERS
Subject Categories: 360601* -- Other Materials -- Preparation & Manufacture
360602 -- Other Materials -- Structure & Phase Studies
400201 -- Chemical & Physicochemical Properties

10/9/16 (Item 10 from file: 103)
DIALOG(R) File 103:Energy SciTec
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01617915 EDB-85-124690

Title: Prints for precision engineering research lathe (Engineering Materials)

Corporate Source: Lawrence Livermore National Lab., CA (USA)

Publication Date: Dec 1982

Report Number(s): CAPE-2944

Order Number: TI85011046

Contract Number (DOE): W-7405-ENG-48

Note: 146 35-mm aperture cards

Document Type: Engineering Material

Language: English

Journal Announcement: ERA8508

Availability: OSTI, PO Bx 62, Oak Ridge, TN 37831

Subfile: ERA (Energy Research Abstracts).

Country of Origin: United States

Country of Publication: United States

Abstract: The precision engineering research lathe (PERL) is a small two-axis, ultra-high-precision turning machine used for turning very small contoured parts. Housed in a laminar-flow enclosure for temperature control, called a clean air envelope, PERL is maintained at a constant 68 degrees F (plus or minus 1 degree). The size of the lathe is minimized to reduce sensitivity to temperature variations. This, combined with internal water cooling of the spindle motor, the only major heat source on the machine, permits the use of air-shower temperature control. (This approach is a departure from previous designs for larger machines where liquid shower systems are used.) Major design features include the use of a T-configuration, hydrostatic oil slides, capstan slide drives, air-bearing spindles, and laser interferometer position feedback. The following features are particularly noteworthy: (1) to obtain the required accuracy and friction characteristics, the two linear slides are supported by 10-cm-travel hydrostatic bearings developed at LLNL; (2) to minimize backlash and friction, capstan drives are used to provide the slide motions; and (3) to obtain the best surface finish possible, asynchronous (nonrepeatable) spindle motion is minimized by driving the spindle directly with a brushless dc torque motor. PERL operates in single-axis mode. Using facing cuts on copper with a diamond tool, surface finishes of 7.5 μ m peak-to-valley (1.5 μ m rms) have been achieved.

Major Descriptors: *LABORATORY EQUIPMENT -- LATHES; *LATHES -- DESIGN; *LATHES -- HYDROSTATIC BEARINGS

Descriptors: MECHANICAL ENGINEERING; SURFACE FINISHING
Broader Terms: BEARINGS; ENGINEERING; EQUIPMENT; MACHINE TOOLS; TOOLS
Subject Categories: 420200* -- Engineering -- Facilities, Equipment, &
Techniques

10/9/17 (Item 11 from file: 103)
DIALOG(R) File 103:Energy SciTec
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00917842 ERA-07-035260; INS-82-009701; EDB-82-092689
Title: Copper coated laser fusion targets using molecular beam levitation
Author(s): Rocke, M.J.
Affiliation: Lawrence Livermore National Laboratory, P. O. Box 5508,
Livermore, California 94550
Source: J. Vac. Sci. Technol. (United States) v 20:4. Coden: JVSTA
Publication Date: Apr 1982
p 1325-1327
Contract Number (DOE): W-7405-ENG-48
Document Type: Journal Article
Language: English
Journal Announcement: EDB8204
Subfile: INS (US Atomindex input); ERA (Energy Research Abstracts).
Country of Origin: United States
Abstract: A series of diagnostic experiments at the Shiva laser fusion
facility required targets of glass microspheres coated with 1.5--3.0
..mu..m of copper. Previous batch coating efforts using vibration
techniques gave poor results due to microsphere sticking and vacuum
welding. Molecular beam levitation (MBL) represented a noncontact
method to produce a sputtered copper coating on a single glass
microsphere. The coating specifications that were achieved resulted in
a copper layer up to 3 ..mu..m thick with the allowance of a maximum
variation of 10 nm in surface finish and thickness. These
techniques developed with the MBL may be applied to sputter coat many
soft metals for fusion target applications.;
Major Descriptors: *COPPER -- SPUTTERING; *COPPER -- SURFACE COATING;
*GLASS -- COATINGS; *MICROSPHERES -- COATINGS
Descriptors: ARGON; GRAIN GROWTH; INERTIAL CONFINEMENT; LASER TARGETS;
MOLECULAR BEAMS; THICKNESS
Broader Terms: BEAMS; CONFINEMENT; DEPOSITION; DIMENSIONS; ELEMENTS; FLUIDS
; GASES; METALS; NONMETALS; PLASMA CONFINEMENT; RARE GASES; TARGETS;
TRANSITION ELEMENTS
Subject Categories: 700208* -- Fusion Power Plant Technology -- Inertial
Confinement Technology
700205 -- Fusion Power Plant Technology -- Fuel, Heating, & Injection
Systems
INIS Subject Categories: A14* -- Plasma Physics & Thermonuclear Reactions
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